



**PATENT**  
Attorney Docket No. NEX-006C  
(formerly ASX-054C)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT(S): Klein et al.  
SERIAL NO.: 09/917,224 GROUP NO.: 2823  
FILING DATE: July 27, 2001 EXAMINER: K. D. Nguyen  
TITLE: Substrate Processing Pallet and Related Substrate Processing  
Method and Machine

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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**RESPONSE**

Sir:

In response to the Office action mailed from the U.S. Patent Office on June 13, 2003, Applicants submit this Response. A petition and appropriate fee for an extension of time for three months, up to and including December 15, 2003, due to the intervening weekend, are submitted herewith. Applicants believe that no additional fees are due, but the Commissioner is hereby authorized to charge any additional required fees to Deposit Account No. 20-0531.

**REMARKS**

Claims 1-17, as filed, remain pending in the application. Applicants thank the Examiner for indicating that claims 13 and 14 are allowable.

**Priority Under 35 U.S.C. § 119**

Applicants request that the Examiner acknowledge the claim for domestic priority under 35 U.S.C. 119(e) to provisional application Serial No. 60/221,030, filed July 27, 2000.